

Applicant: Jae-Goo Lee and Cheol-Ju Yun
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For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

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U.S. PATENT DOCUMENTS

| <u>Exam Init</u> | <u>Ref</u> | <u>Document Number</u> | <u>Issue Date</u> | <u>Name</u> | <u>Class</u> | <u>Sub Class</u> |
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Examiner: _____

Date Considered: _____